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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

OGATA

Atty. Ref.: 461-72

Serial No. 09/931,908

TC/A.U.: 1751

Filed: August 20, 2001

Examiner: Ogata et al

For: THERMISTOR DEVICE, THERMISTOR
DEVICE MANUFACTURING METHOD AND
TEMPERATURE SENSOR

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November 14, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

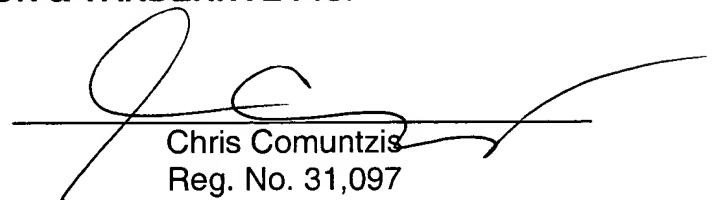
SECOND
STATUS INQUIRY

The Issue Fee for the above-identified application was paid on **May 6, 2004**. A Status Inquiry was filed on **September 12, 2005**. However, since then Applicants have not received any communication from the Patent Office regarding the Patent Grant. Inquiry is made as to when the Patent Grant will be forthcoming.

Respectfully submitted,

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By:


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